



AF/2814

Attorney Docket SEL 144

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki Adachi)
)
Serial No.: 09/437,649)
)
Filed: November 10, 1999)
)
For: Exposure Device, Exposure Method)
And Method Of Manufacturing)
Semiconductor Device)
)
Art Unit: 2814)
)
Examiner: S. Rao)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on
March 31, 2004
(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 3/31/04
Signature Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT C (AFTER FINAL)

Sir:

In response to the Final Rejection dated December 31, 2003, please amend the above-identified application as follows: